

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Dapeng Wang

Serial No.: Not Yet Assigned

Filed: December 5, 2003

**For: DEFORMABLE PAD FOR
CHEMICAL MECHANICAL POLISHING**

Confirmation No.: Unknown

Examiner: Unknown

Group Art Unit: Unknown

**Attorney Docket No.: 2269-3579.2US
(98-0062.02/US)**

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EV326923337US

Date of Deposit with USPS: December 5, 2003

Person making Deposit: Christopher Haughton

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

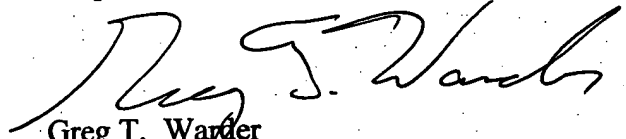
The present application is a divisional of application Serial No. 09/617,692, filed July 17, 2000, pending.

Pursuant to M.P.E.P. 2001.06(b), the Examiner is respectfully requested to consider the information of record in the prior application, and to confirm in the first Office Action on the merits that such art has in fact been reviewed. A PTO-1449 form listing all of the information of record in the prior application is enclosed herewith.

Attorney Docket No.: 2269-3579.2US

This Information Disclosure Statement is filed within three (3) months of the filing date of the above-identified application, and no certification pursuant to 37 C.F.R. § 1.97(c) or a fee pursuant to 37 C.F.R. 1.17(p) is required.

Respectfully submitted,



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Date: December 5, 2003

GTW/ps:ljb

Enclosures: Form PTO-1449

Document in ProLaw

Form PTO-1449 <div style="border: 1px solid black; border-radius: 50%; padding: 10px; display: inline-block; text-align: center;"> OFFICE INFORMATION DISCLOSURE CITATION IN AN APPLICATION MAR 07 2005 <small>(Use several sheets if necessary)</small> </div>		Docket Number (Optional) 3579.2US (98-0062.02/US)		Application Number Not Yet Assigned	
Applicant Dapeng Wang		Filing Date December 5, 2003		Group Art Unit Unknown	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,232,875	08/1993	Tuttle et al.			
	5,514,245	05/1996	Doan et al.			
	5,624,299	04/1997	Shendon			
	5,664,989	09/1997	Nakata et al.			
	5,692,947	12/1997	Talieh et al.			
	5,692,950	12/1997	Rutherford et al.			

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	57023965 A	02/1982	JP				
	58045861 A	03/1983	JP				

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
		Wang et al., <u>Von Mises Stress in Chemical-Mechanical Polishing Processes</u> , J. Electrochem. Soc., Vol. 144, No. 3, March 1997 pp. 1121-27.

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance not considered. Include copy of this form with next communication to the applicant.



THE PATENT & TRADEMARK OFFICE MAILROOM DATE
STAMPED HEREON IS AN ACKNOWLEDGEMENT THAT ON THIS
DATE THE PATENT & TRADEMARK OFFICE RECEIVED:

Utility Patent Application Transmittal (1 page); Fee Transmittal for FY 2004
(1 page, in duplicate); Check No. 19668 in the amount of \$860.00;
Specification, including cover page, claims and single-page abstract (26
pages); Formal Drawings (13 sheets; 23 figures); Copy of Declaration for
Patent Application (with Power of Attorney) (1 page); Copy of Associate
Power of Attorney (1 page); Information Disclosure Statement (2 pages);
and Form PTO-1449 (1 page)

Invention: DEFORMABLE PAD FOR CHEMICAL
MECHANICAL POLISHING
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